



Docket No.: SON-1968
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masakazu Muroyama, et al

Application No.: 09/739,739

Group Art Unit: 2882

Filed: December 20, 2000

Examiner: E. Gemmell

For: CATHODE FOR AN ELECTRON EMISSION
DEVICE, COLD CATHODE FIELD EMISSION
DEVICE AND METHOD FOR THE
PRODUCTION THEREOF, AND COLD
CATHODE FIELD EMISSION DISPLAY AND
METHOD FOR THE PRODUCTION
THEREOF HAVING A CARBON FILM
SELECTIVE-GROWTH REGION (As
Amended)

AMENDMENT

Mail Stop Non-Fee Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated February 12, 2003 (Paper No. 8), please amend
the above-identified U.S. patent application as follows:

In the Title

Please change the title of the invention from Electron Emission Device, Cold Cathode Field Emission Device And Method For The Production Thereof, And Cold Cathode Field Emission Display And Method For The Production Thereof to Cathode For An Electron Emission Device, Cold Cathode Field Emission Device And Method For The Production Thereof, And Cold Cathode Field Emission Display And Method For The Production Thereof Having A Carbon Film Selective-Growth Region